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Docket No. 260615US2X PCT
IN RE APPLICATION OF: Kenichi HAMA, et al.
SERIAL NO: 10/511,607
FILED: November 4, 2004
FOR: METHOD AND DEVICE FOR CLEANING RAW MATERIAL GAS INTRODUCTION TUBE USED IN CVD FILM FORMING APPARATUS

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:
Transmitted herewith is an amendment in the above-identified application.

- ☐ No additional fee is required
☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	64	MINUS	62	2	x \$50 =	\$100.00
INDEPENDENT	7	MINUS	7	0	x \$200 =	\$0.00
APPLICATION SIZE	87	MINUS	100	0 (each addtl. 50 sheets)	x \$250 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$360 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$100.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		TOTAL				\$100.00

- ☐ A check in the amount of **\$0.00** is attached.
- ☒ Credit card payment form is attached to cover the fees in the amount of **\$100.00**
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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DOCKET NO: 200615US2X PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
KENICHI HAMA, ET AL. : EXAMINER: CHEN, BRET P
SERIAL NO: 10/511,607 :
FILED: NOVEMBER 4, 2004 : GROUP ART UNIT: 1762
FOR: METHOD AND DEVICE FOR :
CLEANING RAW MATERIAL GAS
INTRODUCTION TUBE USED IN CVD
FILM FORMING APPARATUS

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated March 17, 2006, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 17 of this paper.